

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: (Divisional of 09/853,090)

Filing Date: Herewith

Applicant: Yoshiaki EMOTO

Group Art Unit: 2827

Examiner: Luan C. Thai

Title: SEMICONDUCTOR DEVICE AND METHOD FOR  
MANUFACTURING THE SAME

Attorney Docket: 9319S-208DVA

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Director of the United States Patent and Trademark Office  
P.O. Box 1450  
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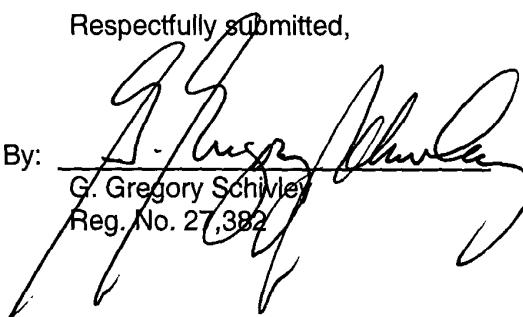
INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with the statutory provisions set forth in 37 CFR § 1.97 and 1.98, the Examiner is hereby respectfully advised of the references listed on the attached PTO-1449 Form. All of these references were made of record during prosecution of the parent application from which this divisional claims priority.

The listed references are cited only in the interest of candor and without any admission that they constitute statutory prior art, or contain matter which anticipates the invention or which would render the same obvious, either singly or in combination, to a person of ordinary skill in the art.

Respectfully submitted,

By: 

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Dated: September 18, 2003

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FORM HDP-1449 (Based on Form PTO-1449)		ATTORNEY DOCKET NO.	SERIAL NO.
		9319S-208DVA	
		APPLICANT	
		Yoshiaki EMOTO	
		FILING DATE	GROUP
		Herewith	2827
Sheet 1 of 1			

<b>U.S. PATENT DOCUMENTS</b>						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.		6,147,401	Nov/2000	Solberg, Vernon		

<b>FOREIGN PATENT DOCUMENTS</b>						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes      No
1.		11-135537	May/1999	Japan		
2.		10-005221	Jan/1998	Japan		
3.		09-331599	Dec/1997	Japan		

<b>OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)</b>						
Ref. Desig.	Examiner's Initials					
1.						

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Examiner:	Date Considered:
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EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.